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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8585**
Takashi OHSAKO et al. : Attorney Docket No. 2003_1364A
Serial No. 10/677,221 : Group Art Unit 2823
Filed October 3, 2003 : Examiner Joannie Garcia
METHOD OF MANUFACTURING : **Mail Stop: AF**
SEMICONDUCTOR ELEMENT

AMENDMENT AFTER FINAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated October 30, 2007, please amend the
above-identified application as follows.

**RESPONSE UNDER 37.CFR1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2823**

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975